



Attorney's Docket No.: 06618-662001/CIT 3252

#6/13
2/2/03

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yu-Chong Tai et al. Art Unit: 2855
Serial No.: 09/900,743 Examiner: Alandra Ellington
Filed : July 6, 2001 Confirmation No. 4560
Title : SURFACE-MICROMACHINED PRESSURE SENSOR AND HIGH
PRESSURE APPLICATION

Commissioner for Patents
Washington, D.C. 20231

RESPONSE

In response to the action mailed November 7, 2002, please
amend the application as follows:

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I hereby certify that this correspondence is
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